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TRAN	ISMITTA	L OF INFORMA (Under 37 CFF	Docket No. P0387							
In Re Application Of: Erwan Le Roy et al OCT 2 9 2004										
Applica	ation No.	Filing Date	Group Art Unit	Confirmation No.						
10/78	89,336	02/27/2004	na	na	na	9033				
Title: METHOD AND APPARATUS FOR THE IMPROVEMENT OF MATERIAL/VOLTAGE CONTRAST										
	Address to:  Commissioner for Patents  P.O. Box 1450  Alexandria, VA 22313-1450									
			37 CFR 1.97(b)							
1. A The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.										
		/ _	37 CFR 1.97(c)							
2.  The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:										
☐ the statement specified in 37 CFR 1.97(e);										
OR										
	☐ the	fee set forth in 37 CF	FR 1.17(p).							

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10/789,336	02/27/2004	na	_	na	na	9033					
Title:											
Payment of Fee  (Only complete if Applicant elects to pay the fee set forth in 37 CER 1 17(n))											
☐ The Director as describe ☐ Ch	as described below.  Charge the amount of Credit any overpayment.										
_	arge any additional fo v credit card. Form P	TO-2038 is attached									
WARNING	: Information on thi	s form may become e credit card inform	public. C	redit card info authorization	ormation should on PTO-2038.	d not be					
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account is being	document and authoriza ng facsimile transmitted nemark Office (Fax. No.		I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on								
			Delmanie weren								
	Signature		Signature of Person Mailing Correspondence  Deborah W. Wenocur								
Typed or I	Printed Name of Person Sig	ning Certificate	Typed or Printed Name of Person Mailing Certificate								
*This certificate may only be used if paying by deposit account.											
Blena	hw.Wll Signature	w	Dated:	Oct. 25, 2004							
Deborah W. Wenocur, Reg. No. 40,221											
Agent for Applicant											
c/o Shelly Garrett	·										
Credence Systems Corp											
1421 California Circle Milpitas, CA 95035											
winpitas, CA 95055	тирииз, Сл. 20000										
cc:											

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